



Attorney Docket No. 0756-7289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/820,781

Filed: April 9, 2004

For: BEAM IRRADIATION APPARATUS,

BEAM IRRADIATION METHOD, AND

METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: S. Isaac

) CERTIFICATE OF MAILING

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Adelle M. Stamps

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.